

Search Notes

Application/Control No.

10/676,145

Examiner

Paul D. Kim

Applicant(s)/Patent under
Reexamination

HA, TAE-HOE

Art Unit

3729

SEARCHED

Class	Subclass	Date	Examiner
29	603.03	11/1/2005 ↓	PK
	729		
	737		
	757		
	759		
360	98.07		
	98.0		
	99.08	↓	
	99.1		

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Text Search EAST/NPL (IEEE)	11/1/2005	PK
Reviewed Relative Application 10/676,144	11/1/2005	PK
Updated Text Search EAST	4/20/2006	PK